## Notice of References Cited Application/Control No. O9/663,811 Applicant(s)/Patent Under Reexamination HACHERL ET AL. Examiner Shin-Hon Chen Applicant(s)/Patent Under Reexamination HACHERL ET AL. Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,839,843	01-2005	Bacha et al.	713/176
	В	US-			
	С	US-			
	D	US-			
	Ε	US-			
	F	US-			
	G	US-			
	Н	US-			
	1	US-			
	J	US-			
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## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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## **NON-PATENT DOCUMENTS**

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